

FIG. 1a
(Prior Art)

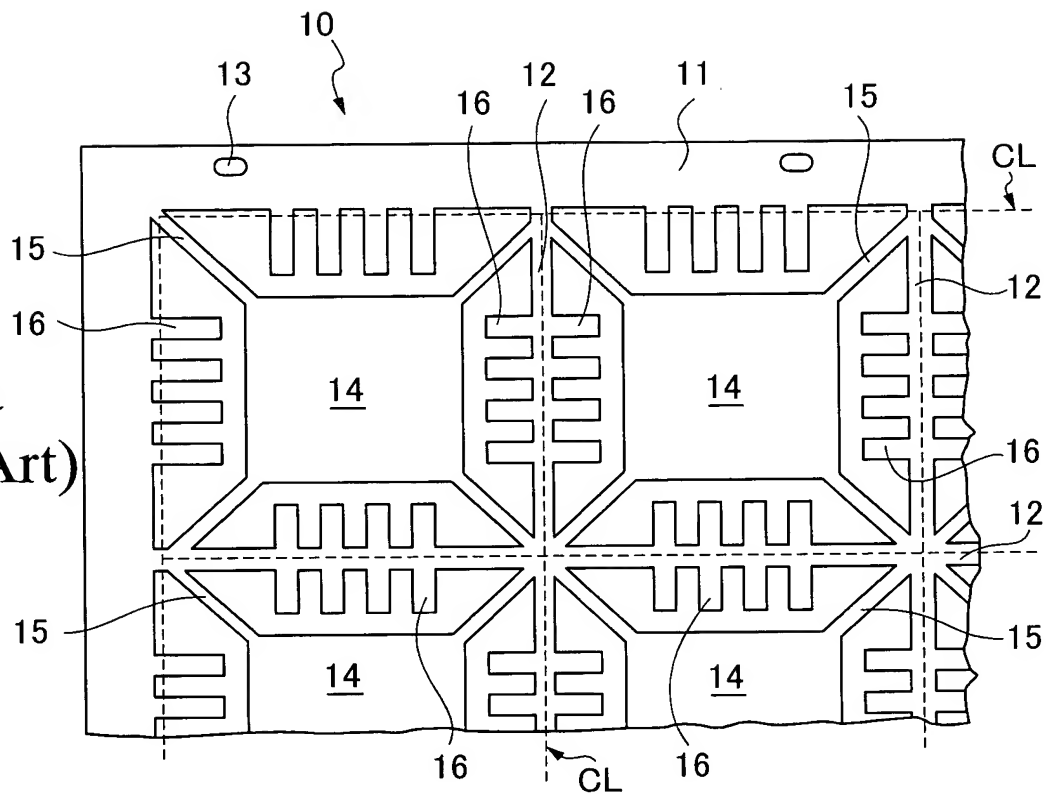


FIG. 1b
(Prior Art)

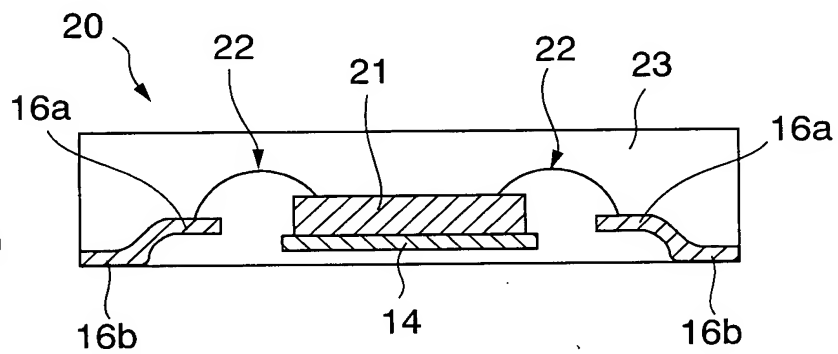


FIG. 1c
(Prior Art)

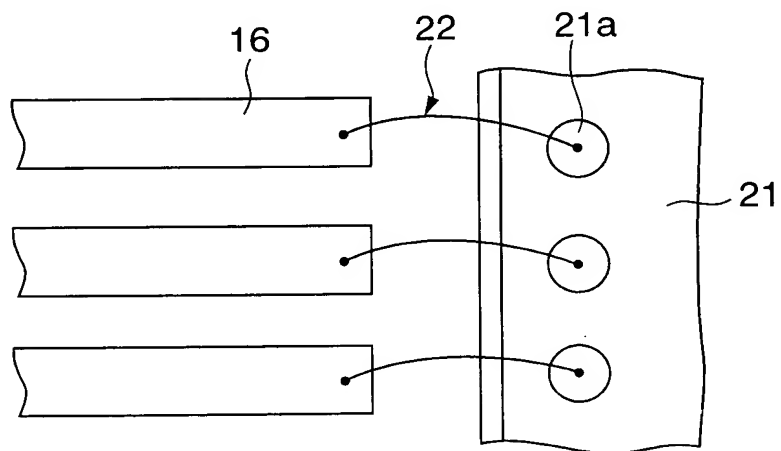


FIG. 2a

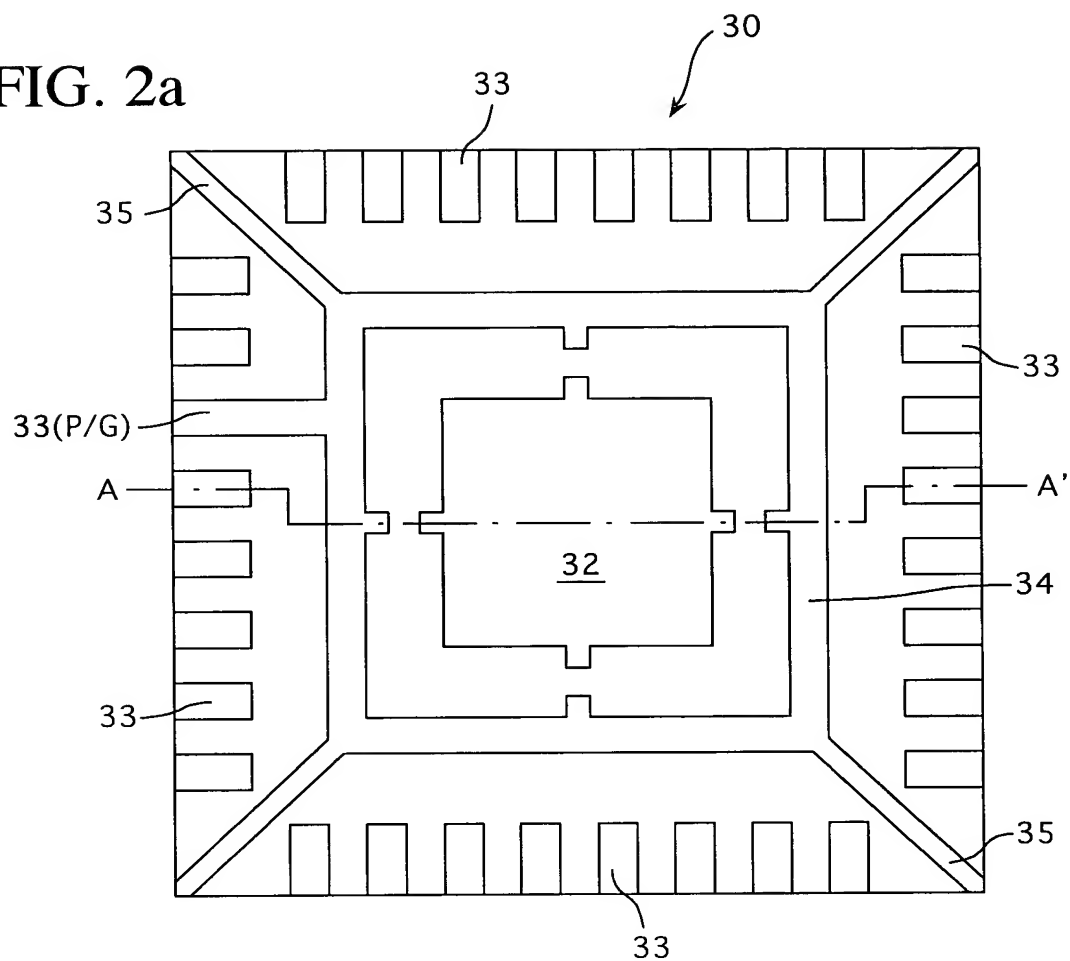


FIG. 2b

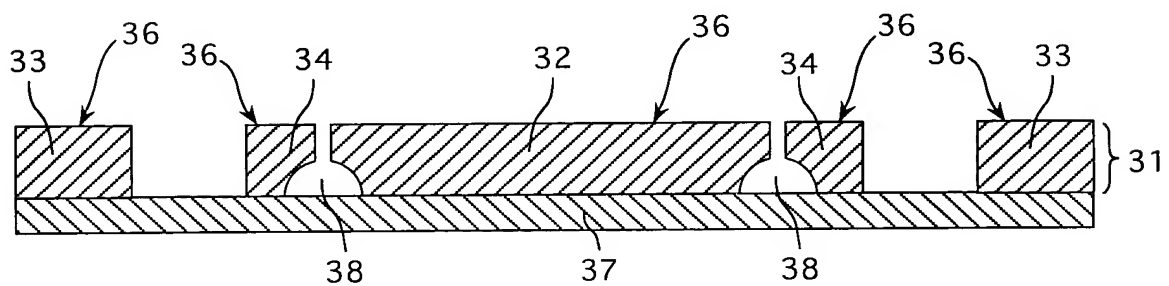


FIG. 3

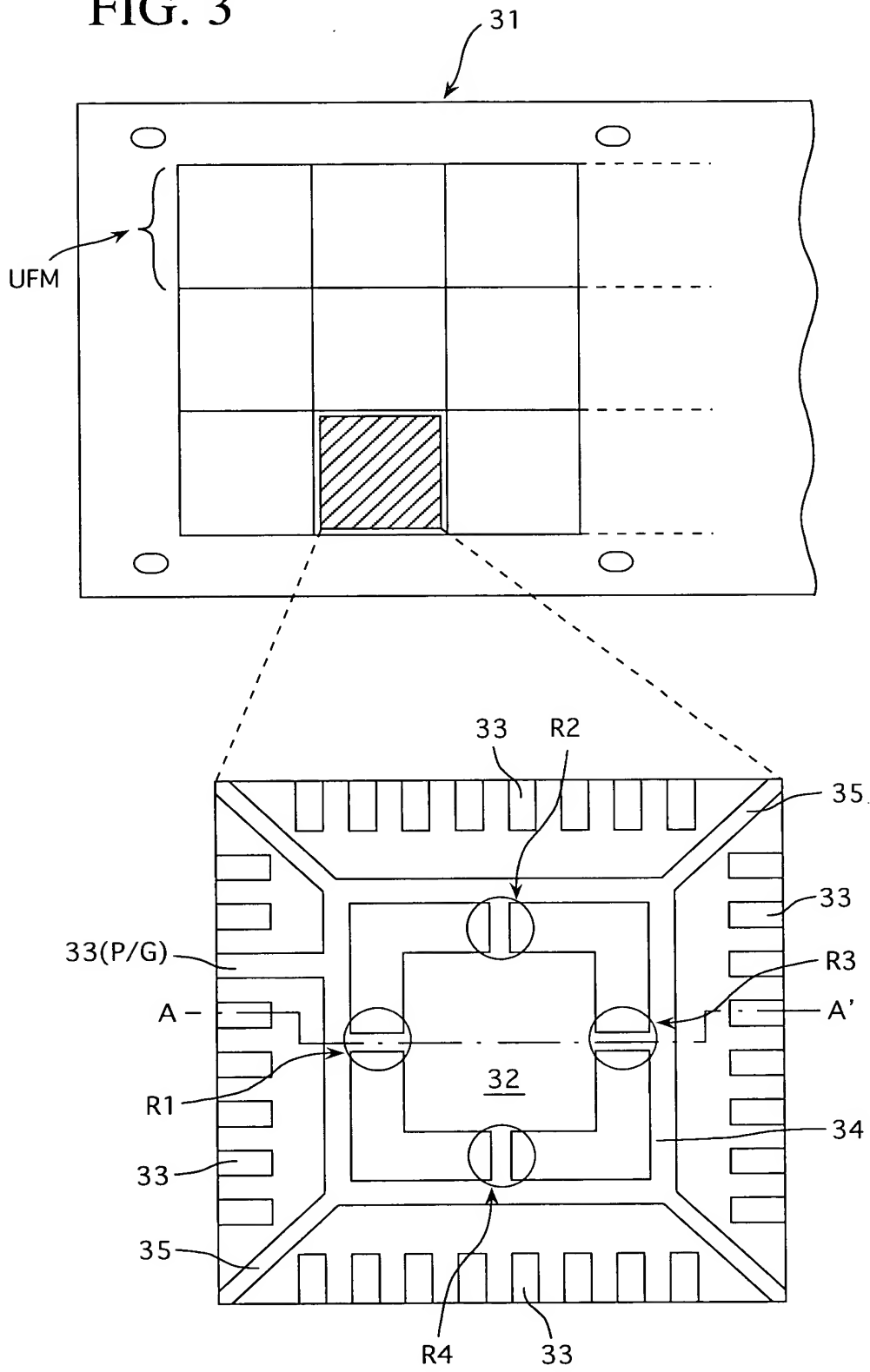


FIG. 4a

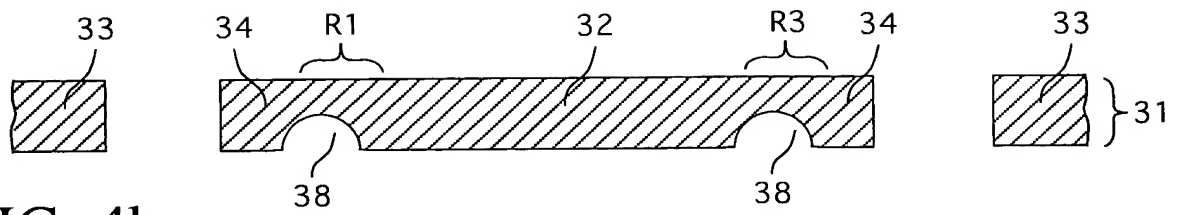


FIG. 4b

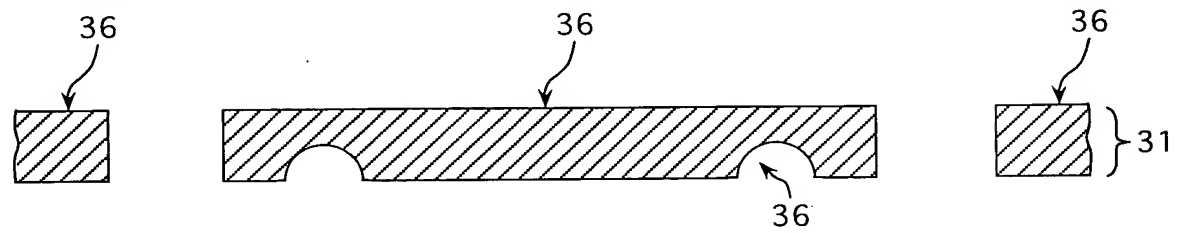


FIG. 4c

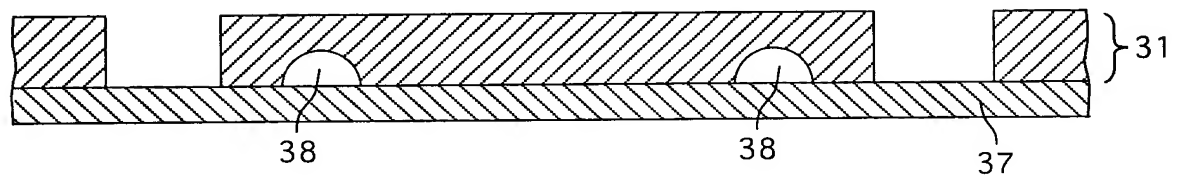


FIG. 4d

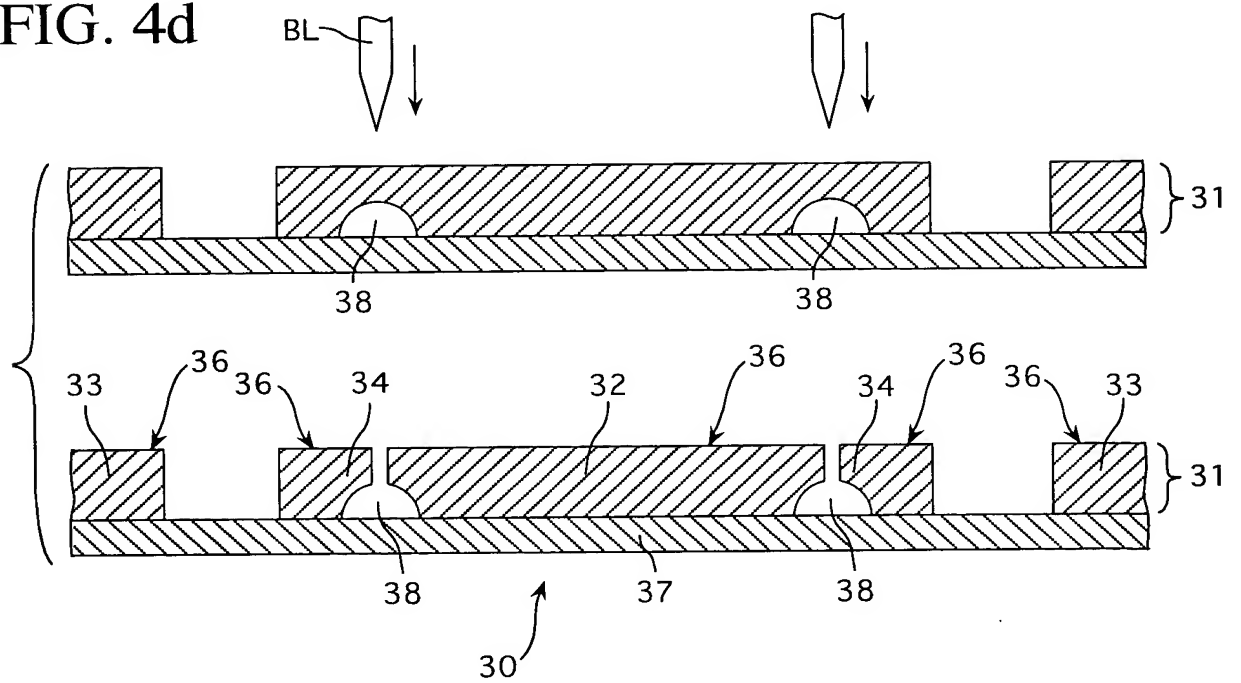


FIG. 5a

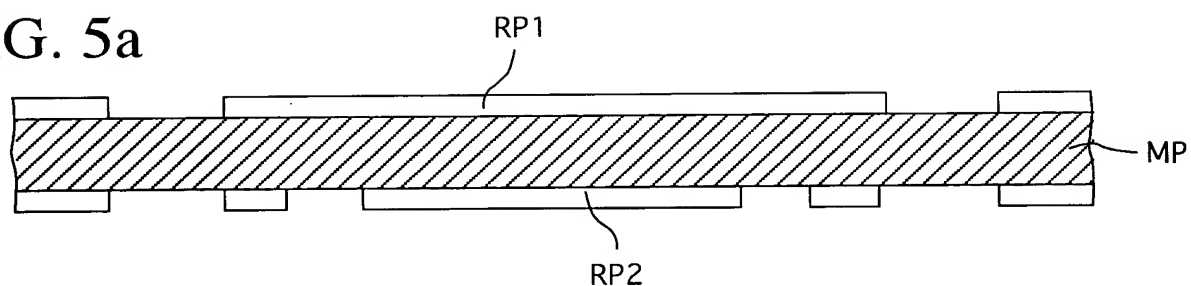


FIG. 5b

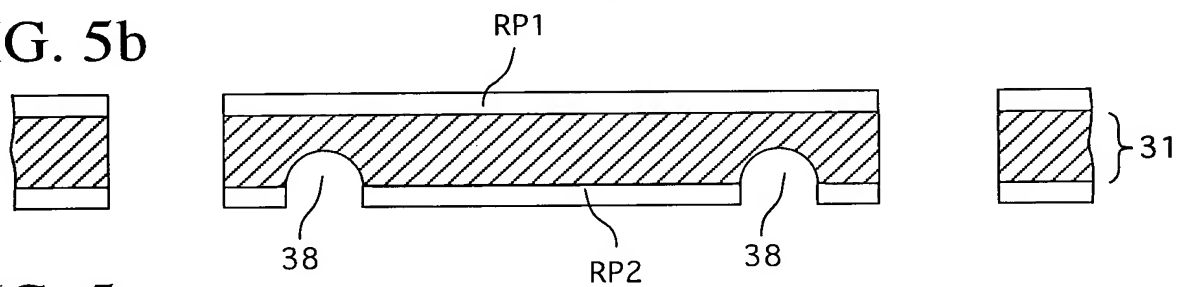


FIG. 5c

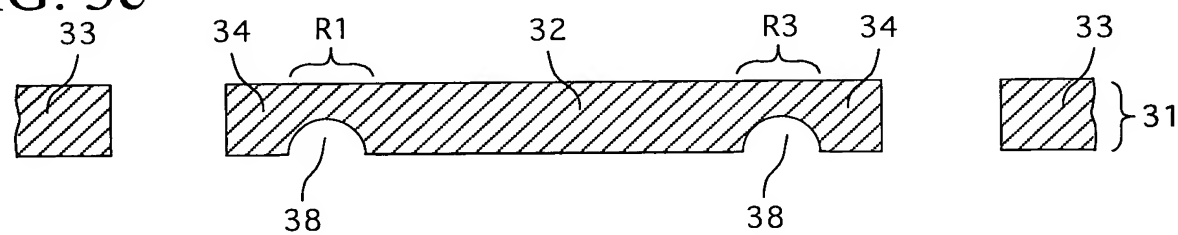


FIG. 6a

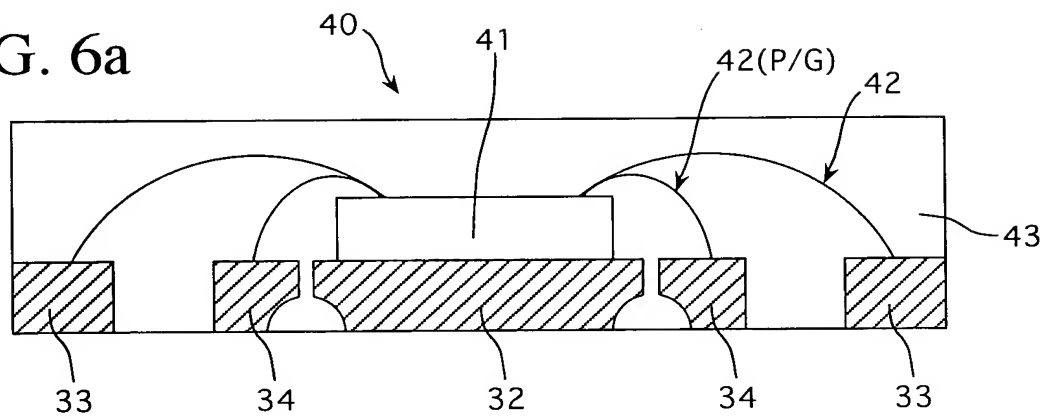


FIG. 6b

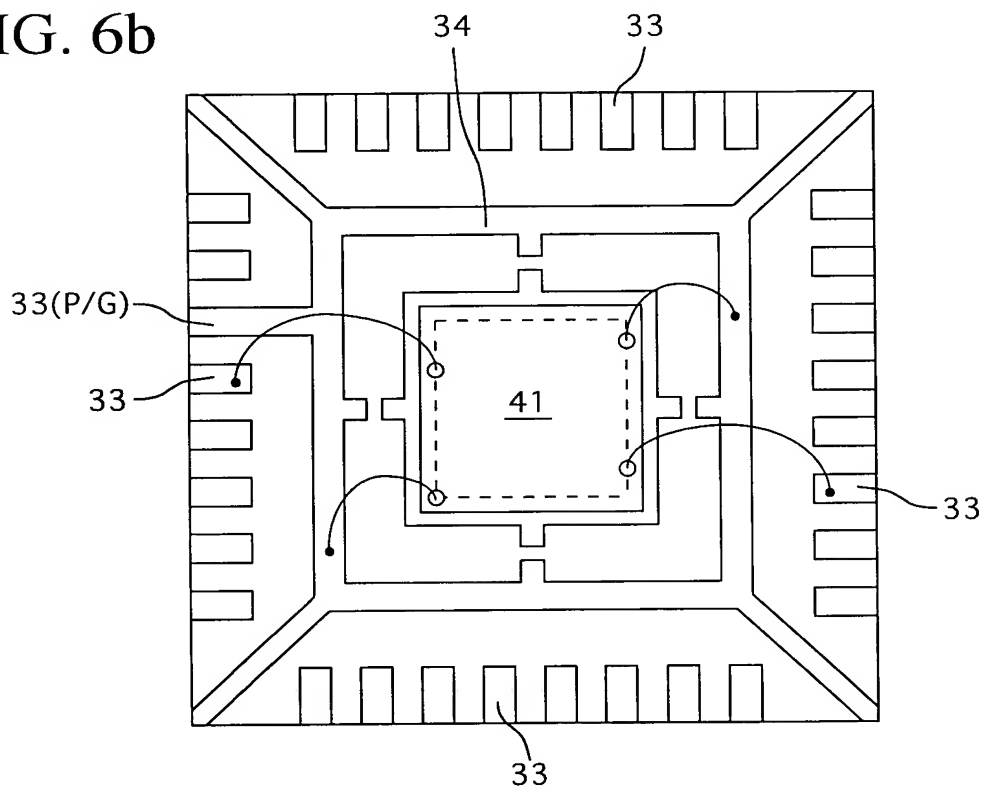


FIG. 7a

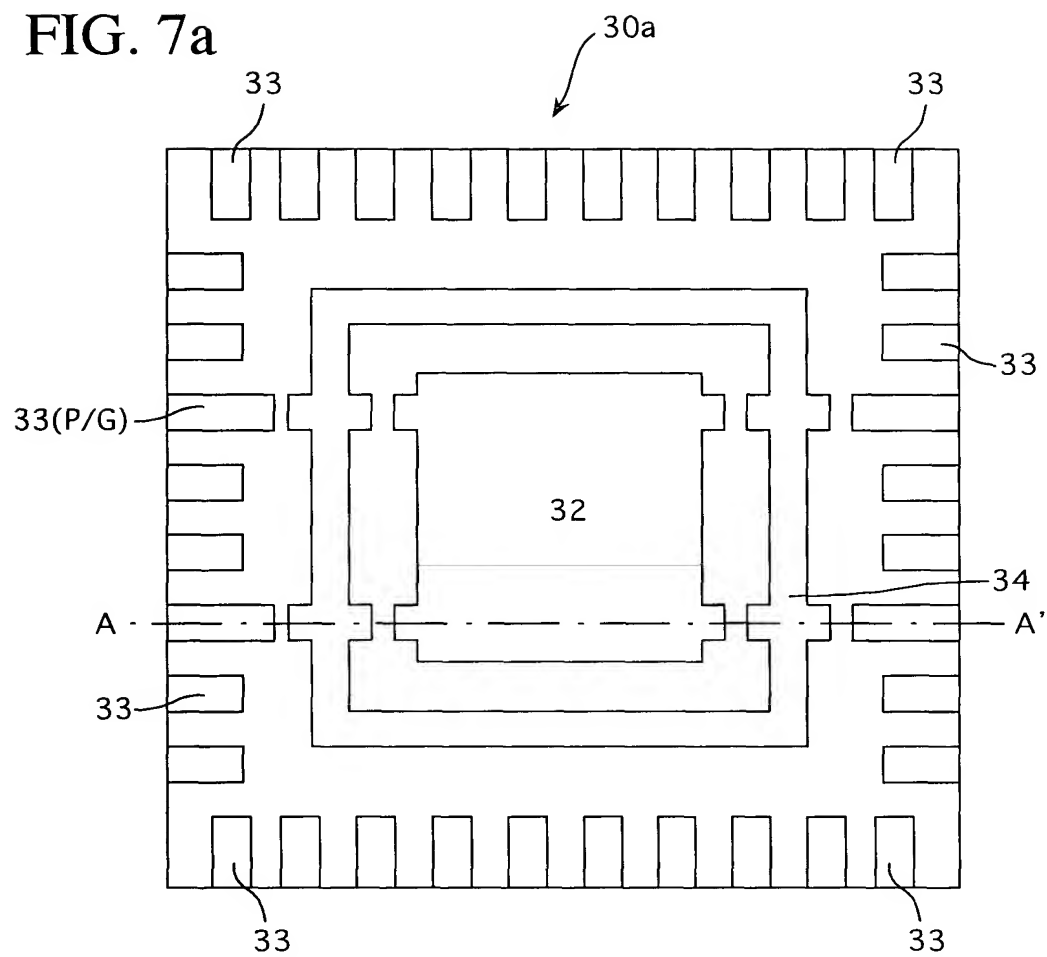


FIG. 7b

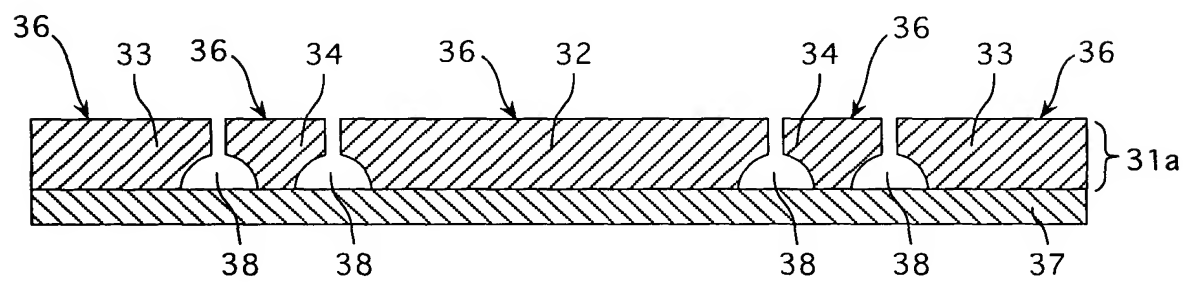


FIG. 8

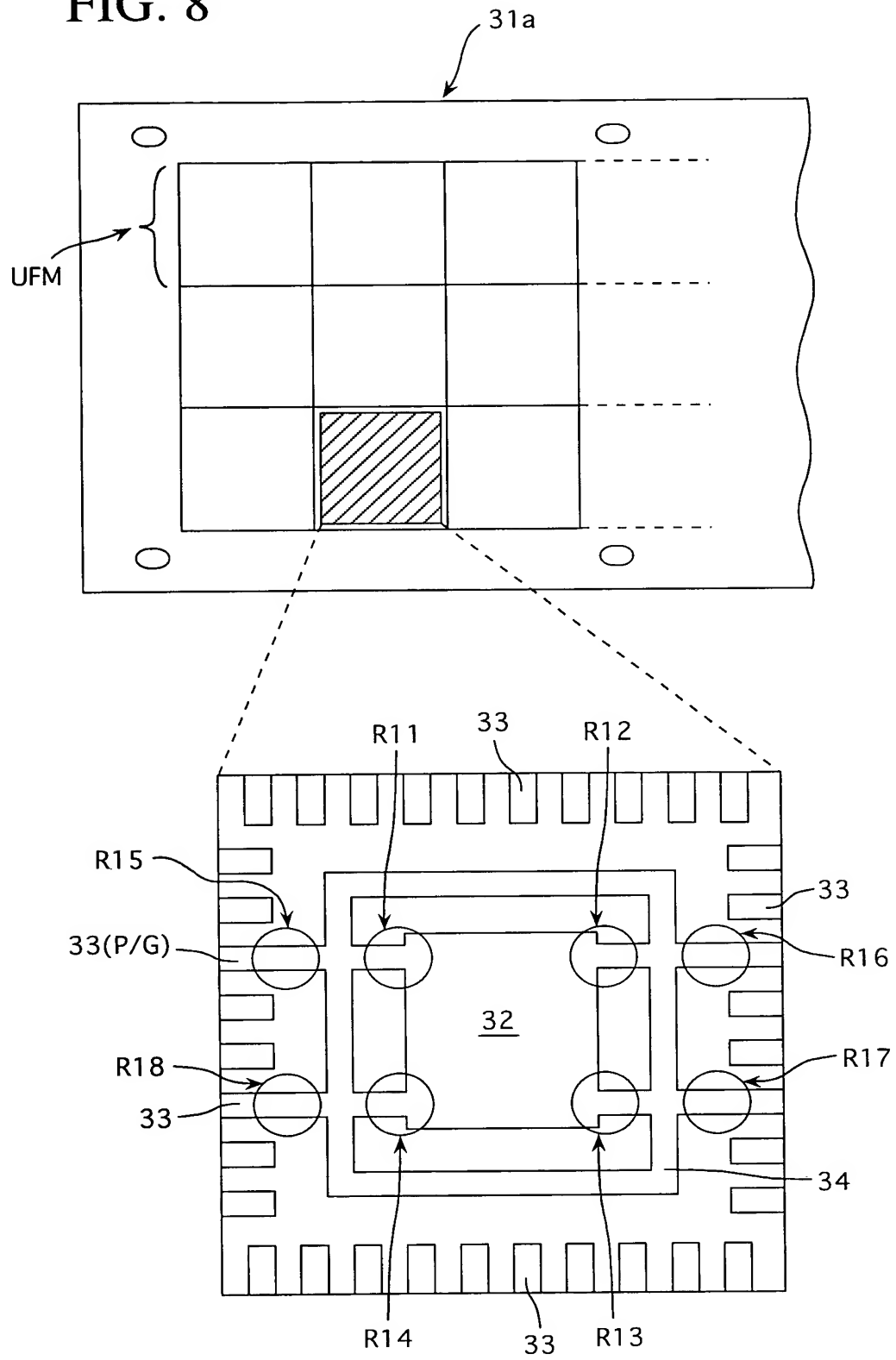


FIG. 9a

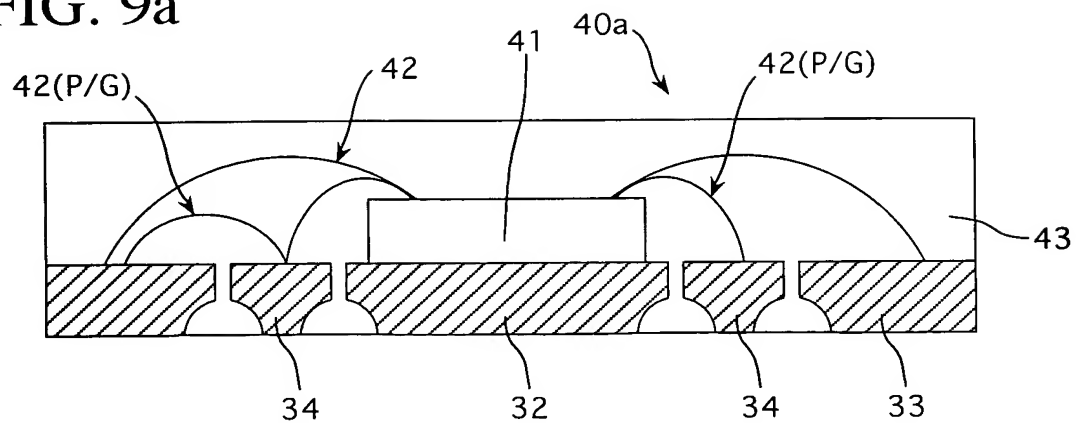


FIG. 9b

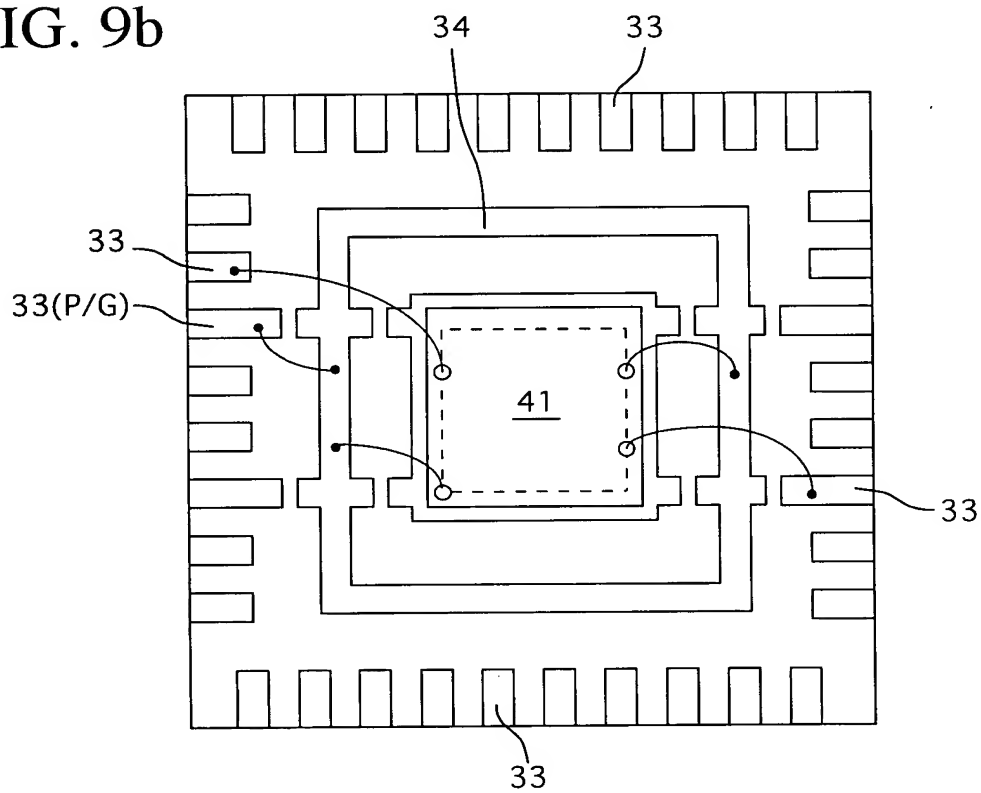


FIG. 10a

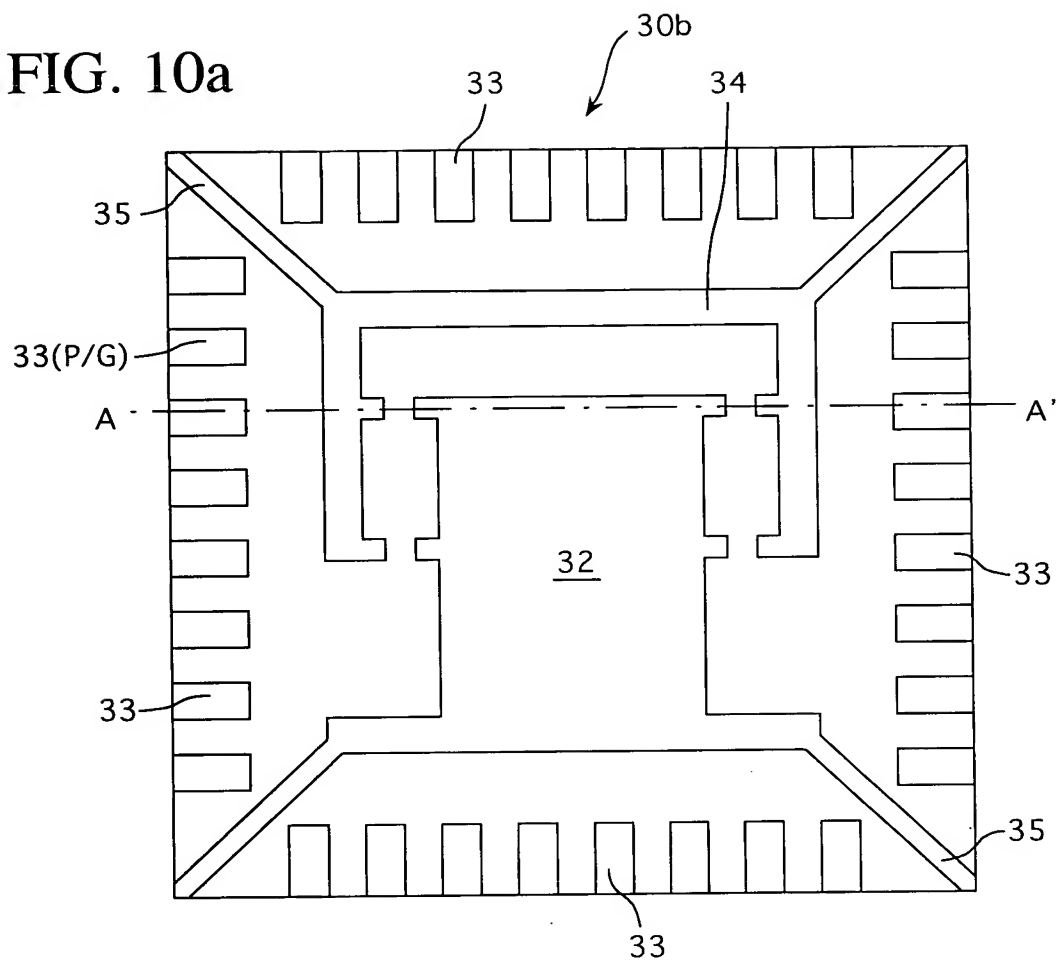


FIG. 10b

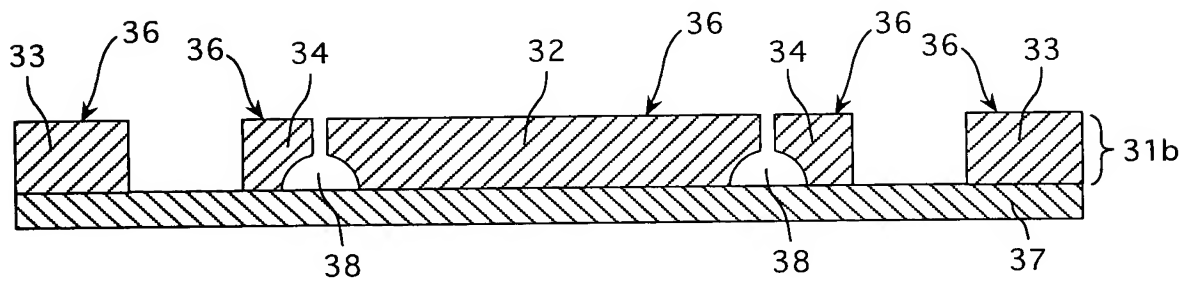


FIG. 11

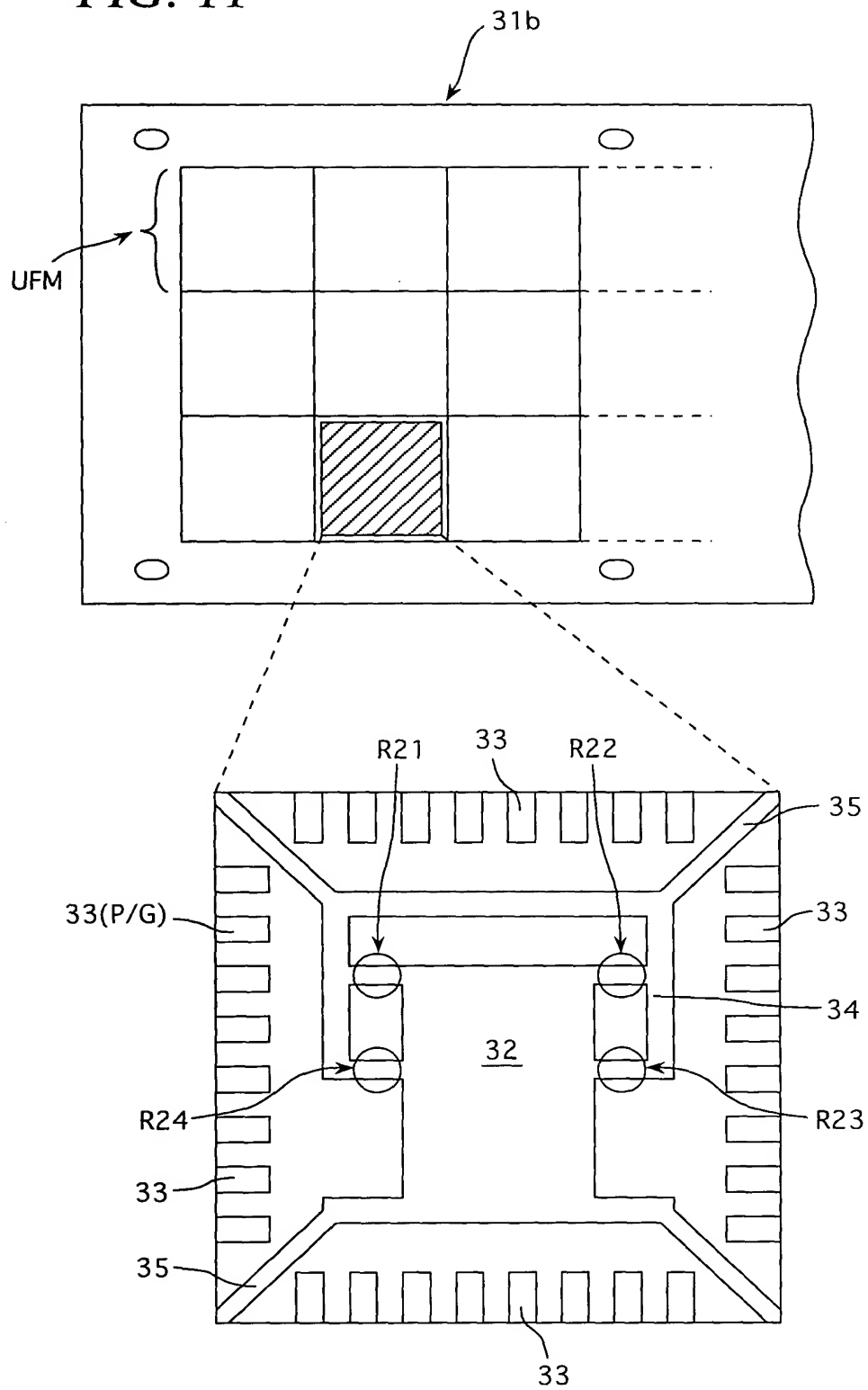


FIG. 12a

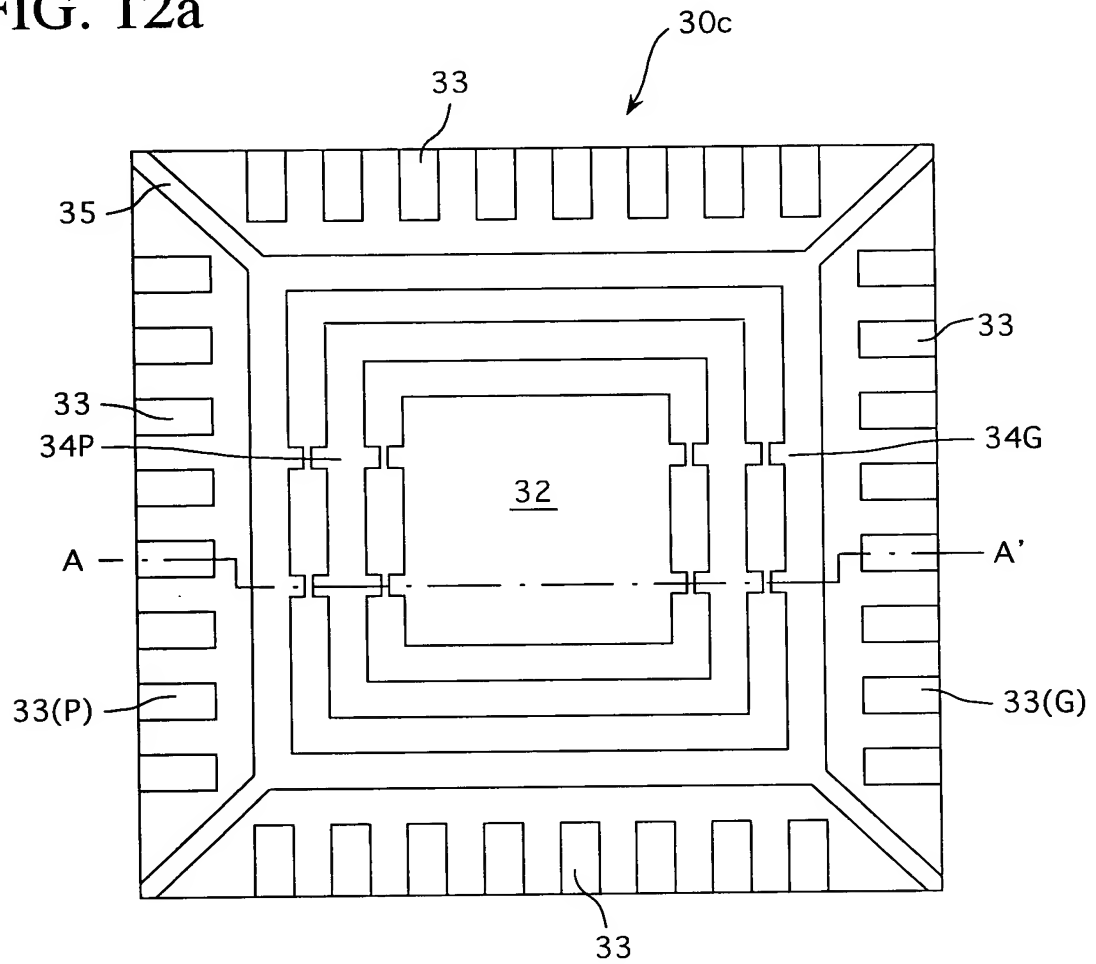


FIG. 12b

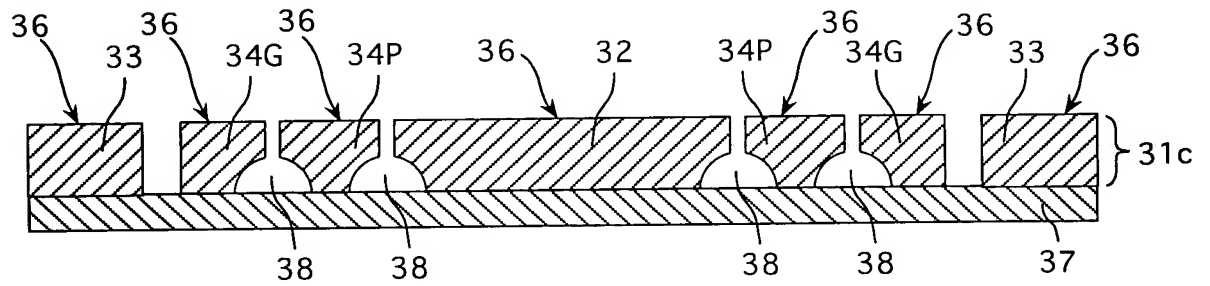


FIG. 13

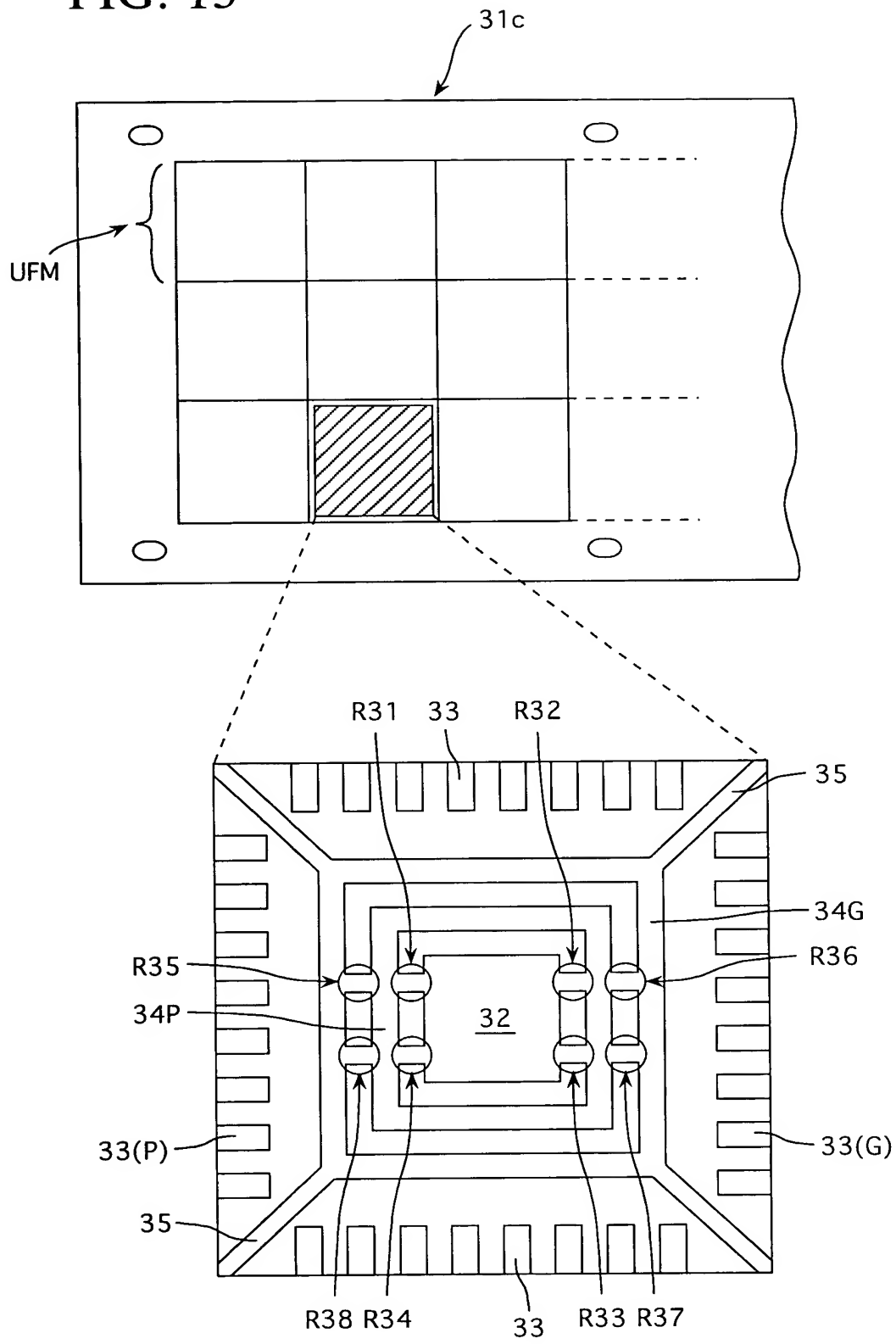


FIG. 14a

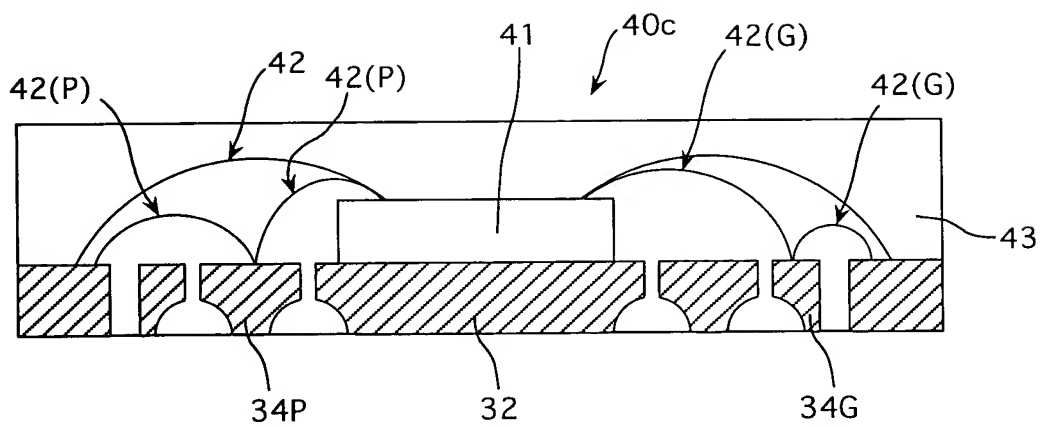


FIG. 14b

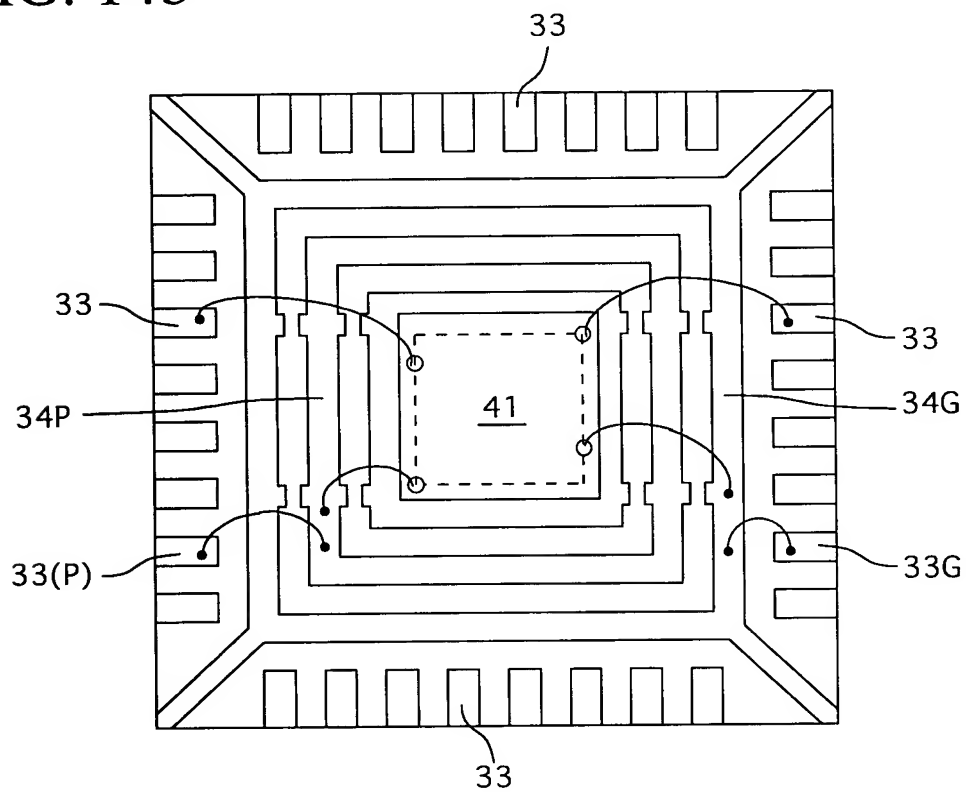


FIG. 15a

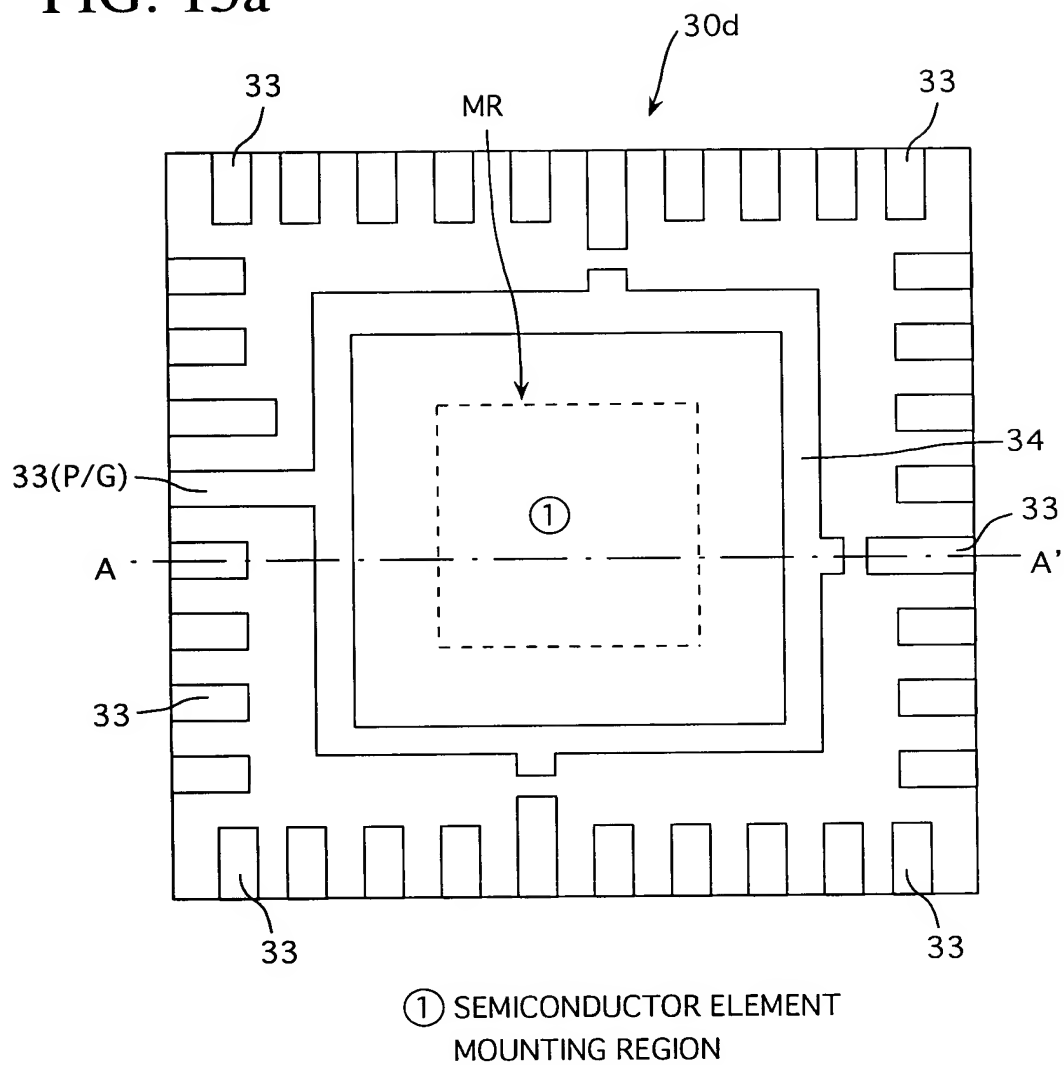


FIG. 15b

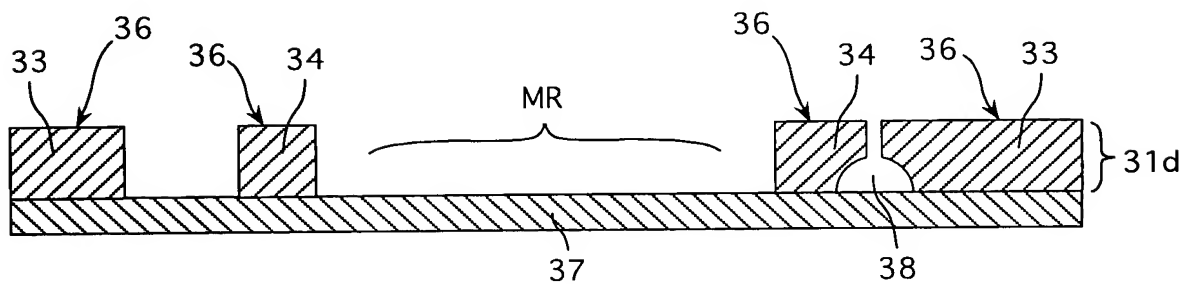
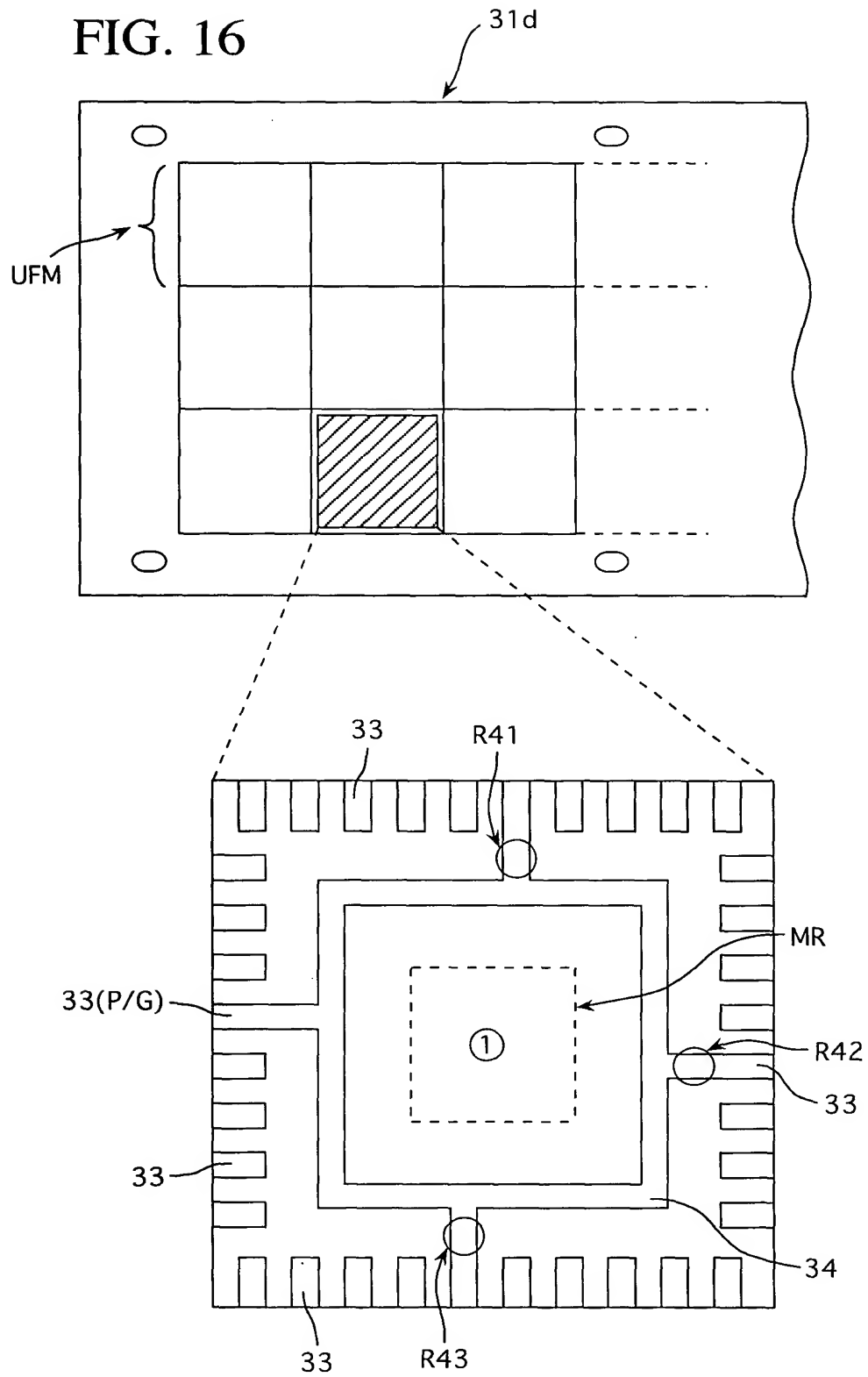


FIG. 16



① SEMICONDUCTOR ELEMENT
MOUNTING REGION

FIG. 17a

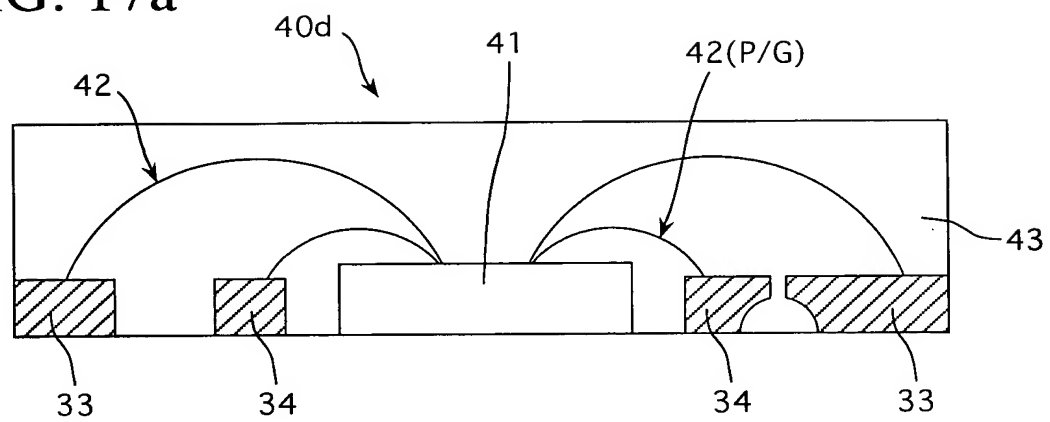


FIG. 17b

